



Response Under 37 C.F.R. § 1.116
Expedited Procedure
Examining Group 1746

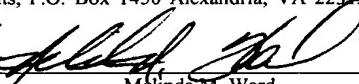
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:) Attorney Docket No: LAM1P108D
Mikhaylich et al.)
Application No: 10/766,733) Examiner: MARKOFF, A.
Filed: January 27, 2004) Group Art Unit: 1746
For: METHOD AND SYSTEM FOR CLEANING A) Date: April 12, 2006
SEMICONDUCTOR WAFER)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on April 12, 2006.

Signed: 
Melinda M. Ward

Commissioner for Patents
Mail Stop AF
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application. The fee has been calculated as shown below.

	Claims Remaining <u>After Amendment</u>	Highest Previously <u>Paid For</u>	Present <u>Extra</u>	SMALL ENTITY <u>RATE FEE</u>	OR	LARGE <u>RATE FEE</u>	ENTITY
TOTAL CLAIMS	<u>19</u> -	<u>20</u>	<u>00</u>	X25 = \$	OR	X50 = \$	
INDEP CLAIMS	<u>02</u> -	<u>03</u>	<u>00</u>	X100 = \$	OR	X200 = \$	
[] Multiple Dependent Claim Present and Fee Not Previously Paid				\$180		X360	\$
			TOTAL	\$ _____		\$ _____	

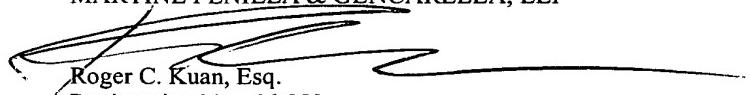


Applicant(s) hereby petition for a one-month extension of time to respond to the outstanding Office Action. Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM1P108D).



Enclosed is Check No. in the amount of \$ to cover the additional extension of time fees. If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM1P108D). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE PENILLA & GENCARELLA, LLP


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Melinda M. Ward

AMENDMENT

Mail Stop AF
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is in response to a Final Office Action dated March 8, 2006, term to respond extends to May 8, 2006. Please enter this Amendment and remarks.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.